



No sample pre-treatment
No Heated Lines*
Multi-Components
Pre-Calibrated
No interference
No Drift

Compliant to standard EN 15267-3 : 2008 and QAL 1 de EN 14181







AWARD 2010

On-line monitoring

LaserCEM gas analyzers

Low Pressure Sampling
Extremely High Resolution Laser

Emission monitoring

- Waste incinerators plants
- Refineries
- Cement plants



- The **LaserCEM** uses the patented OFCEAS (WO 03031949) IR laser technology for enhanced specificity, selectivity, accuracy and stability (no instrumental response drift).
- The **LaserCEM** uses a patented low-pressure sampling system (WO 2010058107) enabling low-cost installation thanks to non-heated lines*and reduced maintenance.
- The LaserCEM is a reliable, robust, low-cost and easy-to-use solution for CEM's analysis.



LaserCEM

Advantages & Benefits

DIRECT MEASUREMENT

No sample pre-treatment.

OFCEAS technology associated with low pressure sampling enables direct measurement. The low pressure in the sampling system removes any risk for chemicals adsorption/desorption and condensation in the line.

NO INTERFERENCE

OFCEAS technology associated with low pressure sampling provides exceptional selectivity, enabling simultaneous multi-component measurement without interferences, regardless of the matrix.

✓ NO RE-ZERO; NO DRIFT

The zero information is contained in the signal, enabling automated and intrinsic re-zero of the analyzer.

EASE-OF-USE

The LaserCEM is pre-calibrated for your CEM's application. Initially packaged in a standard 19"rack, it includes a touch screen interface and on-board PC for local / remote control and real time display / recording of results.

EASE-OF-INTEGRATION

The LaserCEM allows digital (Ethernet, RS485, RS232, ModBus), analog and TDR I/O's.

ROBUSTNESS

The LaserCEM contains no optical moving parts and was designed and built strictly for industrial and on-board mobile applications.

LOW MAINTENANCE

High MTBF

In addition to containing no moving optical components, the IR sources (telecom type laser) are characterized by MTBF's of 5 years.

CLEAN LINES / FILTERS

The low pressure sampling system enables low flow rates (3-9 L/h) without degrading response time. Accumulation of contaminants lines and filters is greatly reduced.

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ATEX compliant configuration available.

SAMPLING	
Flow Rate:	3-9 L/h
Max. Temp.:	600°C
Max. Humidity:	H2O(g) < 40% vol Standard H2O(g) > 40% vol Study Required
Pressure:	1 atm. ± 100 mbar @ sampling point
Sampling Line:	Ambient Temp. > 10°C et H2O <40% vol. > Simple polytube (no heating)
	Ambient Temp. < 10°C et H2O >40% vol. > 40°C heated line
DIMENSIONS	
Size:	standard 19", 4U rack
	550 mm depth.
Weight:	20kg
Options:	Wall mounted ATEX compliant integration
ELECTRONICS	
Display/Control:	5.7" diagonal color touch screen
PC OS:	Windows® XP®
Software:	WinProceas ©
INSTALLATION REQUIREMI	ENTS
Operating Temp.:	15-35°C - Standard 10-40°C - Optional
Power supply:	200 W - 110-220VAC - 50-60Hz
Compressed Air:	1-6 bar (oil free). Not provided.

1/0's		
Standard:	Ethernet Protocol; RS 485 RS 232; ModBus.	
Optional:	Analog I/O; TDR I/O. Other I/O's on request	
ANALYTICAL SPÉCIFICATIONS		
Gas	Range ^a	LOD ^b
SO ₂	0 to 25 ppm / 0 - 75 mg/m³	0.22 ppm
NO	0 to 60 ppm / 0 - 80 mg/m³	0.09 ppm
HCl	0 to 10 ppm /0 - 15 mg/m³	0.01 ppm
NH3	0 to 10 ppm /0 - 15 mg/m³	0.01 ppm
CO	0 to 60 ppm /0 - 75 mg/m³	0.22 ppm
H ₂ 0	0 - 40% Vol	0.1%
02	0 - 25% Vol	0.05%
CO ₂	0 - 20% Vol	0.06%
S0 ₃	0 to 25 ppm /0 - 80 mg/m³	0.20 ppm
N ₂ 0	0-100 ppm /0 - 200 mg/m³	0.09 ppm
CH4	0-100 ppm /0 - 75 mg/m ³	0.11 ppm
NO ₂	0-25 ppm /0 - 50 mg/m³	0.08 ppm
HF	0-10 ppm /0 - 10 mg/m³	0.01 ppm
Response Time	< 200 seconds.	
Zero Drift:	none	
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^a adjustable range on request ^b limit of detection 3 Sigma

LAYOUT FROM SONIC NOZZLE TO LASERCEM ANALYZER

